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**THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Masashi GOTO et al.

Title: **DIELECTRIC FILM, ITS FORMATION METHOD,  
SEMICONDUCTOR DEVICE USING THE DIELECTRIC  
FILM AND ITS PRODUCTION METHOD**

Application No.: 10/726,870

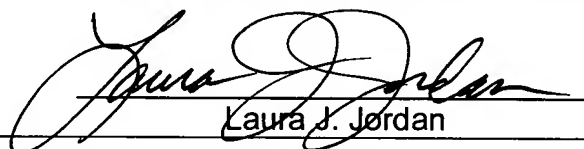
Filing Date: 2 December, 2003

Examiner/Unit: Dao H. Nguyen / 2818

Attorney Docket No.: 2204-011-03

**CERTIFICATE OF MAILING**

I hereby certify that this communication, and any document being attached hereto, is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail addressed to: MS Amendments, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on this 3rd day of March, 2006.

  
Laura J. Jordan

**SUPPLEMENTAL AMENDMENT**

**TO COMMISSIONER FOR PATENTS**

This Supplemental Amendment is being filed to further address issues identified by the Examiner during his interview with applicant's attorney on 26 January 2006. This Supplemental Amendment is intended to clarify the claims while addressing the issues raised by the Examiner during the noted interview. The amendments are not in response to any office action. It should be noted that the changes shown below presume that the Examiner entered applicant's previous response. If this presumption is improper, the Examiner is encouraged to immediately contact the undersigned.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.